

Notice of References Cited	Application/Control No. 10/749,889	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Paul J. Hirsch	Art Unit 3753	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,332,251	12-2001	Ho et al.	24/459
	B	US-6,404,633	06-2002	Hsu, Hsien-Keng	361/703
	C	US-6,449,152	09-2002	Lin, Jen-Cheng	361/697
	D	US-6,643,133	11-2003	Liu, Jefferson	361/704
	E	US-6,771,506	08-2004	Lee et al.	361/704
	F	US-6,236,569	05-2001	McEuen, Shawn S.	361/719
	G	US-5,943,209	08-1999	Liu, Yen-Wen	361/695
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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